

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): TAKAHASHI, et al.

Serial No.: 09/414,520

Filed: October 8, 1999

For: PLASMA PROCESSING APPARATUS AND A PLASMA
PROCESSING METHOD

Group: 1763

Examiner: Zervigon, R.



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PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents
Washington, D.C. 20231

December 3, 2001

Sir:

In the matter of the above-identified application, the applicants hereby respectfully petition for an extension of time to permit filing a response within the first month subsequent to expiration of the shortened statutory period set in the Office Action of August 3, 2001. A credit card payment in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

Please charge any shortage in fees to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (503.37698X00).

12/04/2001 SDENBOB1 00000048 09414520

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110.00 OP

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

Ralph T. Webb

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Attachment